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PATENT
ATTORNEY DOCKET NO.: 46884-5388

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Fumitsugu FUKUYO et al.) Confirmation No.: 4531
U.S. Application No.: 10/537,509)
Filed: November 30, 2005) Group Art Unit: 2812
For: METHOD FOR CUTTING)
SEMICONDUCTOR SUBSTRATE) Examiner: Jairus K. Greene

Commissioner of Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Alexandria, VA 22314

Sir:

AMENDMENT AND RESPONSE TO ELECTION OF SPECIES REQUIREMENT

In response to the Office Action dated November 23, 2007, please amend the above-identified application as follows.

12/28/2007 ATRAN1 00000095 10537509

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